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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

NAKAYAMA ET AL.

Atty. Ref.: 925-342

Serial No. 10/581,247

Group: Unknown

Filed: May 31, 2006

Examiner: Unknown

For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND
MANUFACTURING METHOD THEREFOR

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Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

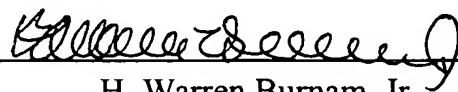
Sir:

STATUS INQUIRY

A national phase application was filed on May 31, 2006. However, since then applicant has not received the **Notice of Acceptance and Official Filing Receipt** from the Patent Office regarding the application. Inquiry is made as to when the **Notice of Acceptance and Official Filing Receipt** be forthcoming. Please direct any response to this inquiry to Linda Hull at telephone number (703) 816-4127.

Respectfully submitted,
NIXON & VANDERHYE P.C.

November 30, 2006

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